

microscope objective / lens positioning system

MIPOS 250

- 250µm focusing range
- compact design
- high resonant frequency
- easy to attach on microscopes
- flexible use by Flex-Adapter
- optionally integrated measurement system

applications:

- surface scanning and analysis
- AFM microscopy
- biotechnology (e.g. cell scanning)
- beam focusing for printing processes
- semiconductor test equipment



fig.: MIPOS 250

Concept

The systems in the MIPOS 250 series offer a nano positioning and scanning range up to $250\mu m$ in open loop operation, as well as $200\mu m$ in closed loop. They can be assembled with objectives that have up to a 40mm diameter.

The successful parallelogram design of *piezosystem jena* guarantees high parallel motion without influencing the optical path.

The positioning repeatability can be guaranteed by an integrated measurement system.

The design with integrated preload of the actuator offers the following advantages:

- high resonant frequency
- highly parallel motion
- upside-down version for inverted microscopes

Based on these features, fast scanning applications can be accurately realized with the shortest settling times.

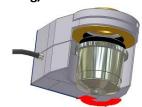
Specials

Adapter thread rings for the nose piece are available separately. They allow for fast mounting and exchanging of the MIPOS system on the microscope. Other objectives no longer need to be removed.

These Flex-Adapters are available for all standard microscopes, and allow the MIPOS series to be universally applicable.

Parfocal tube extensions for each threading type are available as an accessory.

Mounting/Installation



1. Screw the objective into the MIPOS



2. Screw the Flex-Adapter into the microscope



Clamp the MIPOS on the Flex-Adapter using the attachment screw





Spacer rings to compensate the extended optical path are available and flex adapters for all common threads.





technical datas:

series MIPOS			unit	MIPOS 250	MIPOS 250 SG	MIPOS 250 CAP
ı	M25x0.75		-	O-370-00	0-370-01	O-370-06
part no.	W0.8x1/36" (RMS)		-	O-374-00	0-374-01	0-374-06
•	M26x0.75		-	O-375-00	0-375-01	0-375-06
thread	M27x0.75		-	O-376-00	0-376-01	0-376-06
N	M32x0.75		-	O-377-00	0-377-01	0-377-06
axis			-	Z		
motion open loop (±10%)*			μm	250		
motion closed loop (±0,2%)*			μm	- 200		
capacitance (±20%)**			μF	10.2		
integrated measurement system			-	-	strain gage	capacitive
resolution open loop***			nm	0.5		
resolution closed loop***			nm	-	5.0	1.0
typ. repeatability			nm	-	9	8
resonant frequency			Hz	320		
additional load = 80g			Hz	250		
additional load = 105g			Hz	230		
additional load = 300g			Hz	155		
stiffness			N/µm	0.4		
rotational error (full motion)			μrad	<10 <6		
voltage range			V	-20+130		
connector	voltage		-	LEMO 0S 302		
Connector		sensor	-	-	LEMO 0S 304	LEMO 0S.650
cable length		m	1.0	1.2	1.6	
min. bend radius of cable			mm	>15		
material			-	stainless steel		
dimensions (I x w x h)			mm	60.7x50x23.5	60.5x50x35.3	60.2x50x34.5
weight			g	255	255	350
max. lens diameter			mm	40		
max. lens weight			g	500		
option for standard microscopes			-	yes	yes	yes
option for inverse microscopes			-	yes	yes	yes

^{*} typical value measured with NV 40/3 CLE amplifier

recommended configuration:

actuator MIPOS 250 SG O-37X-01E amplifier/controller NV 40/1 CLE E-101-73

The series of micro lens and objective positioning systems MIPOS offers a travel range from $20\mu m$ up to $500\mu m$ in z-axis. Available for standard and inverted microscopes More details under "z-axis-lens-positioning" www.piezojena.com.

Additional microscopy stages for XY axes available under "series-PXY-AP" www.piezojena.com

Rights reserved to change specifications as progress occurs without notice!



^{**} typical value for small electrical field strength

^{***} The resolution is only limited by the noise of the power amplifier and metrology.

^{****}in combination with a digital controller unit the system comes with a Sub-D 15 connector.

The part number is extended by the suffix "D".